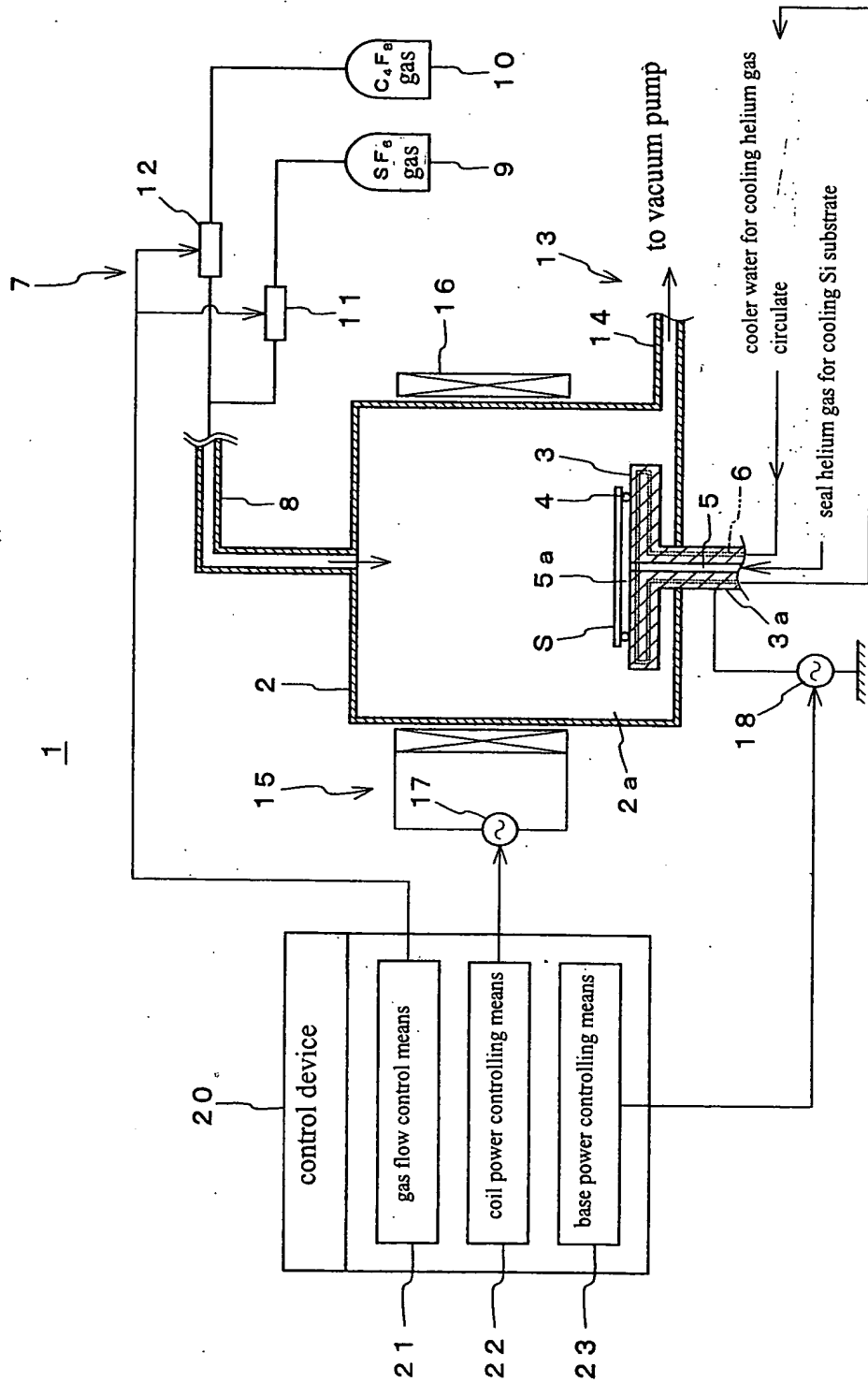


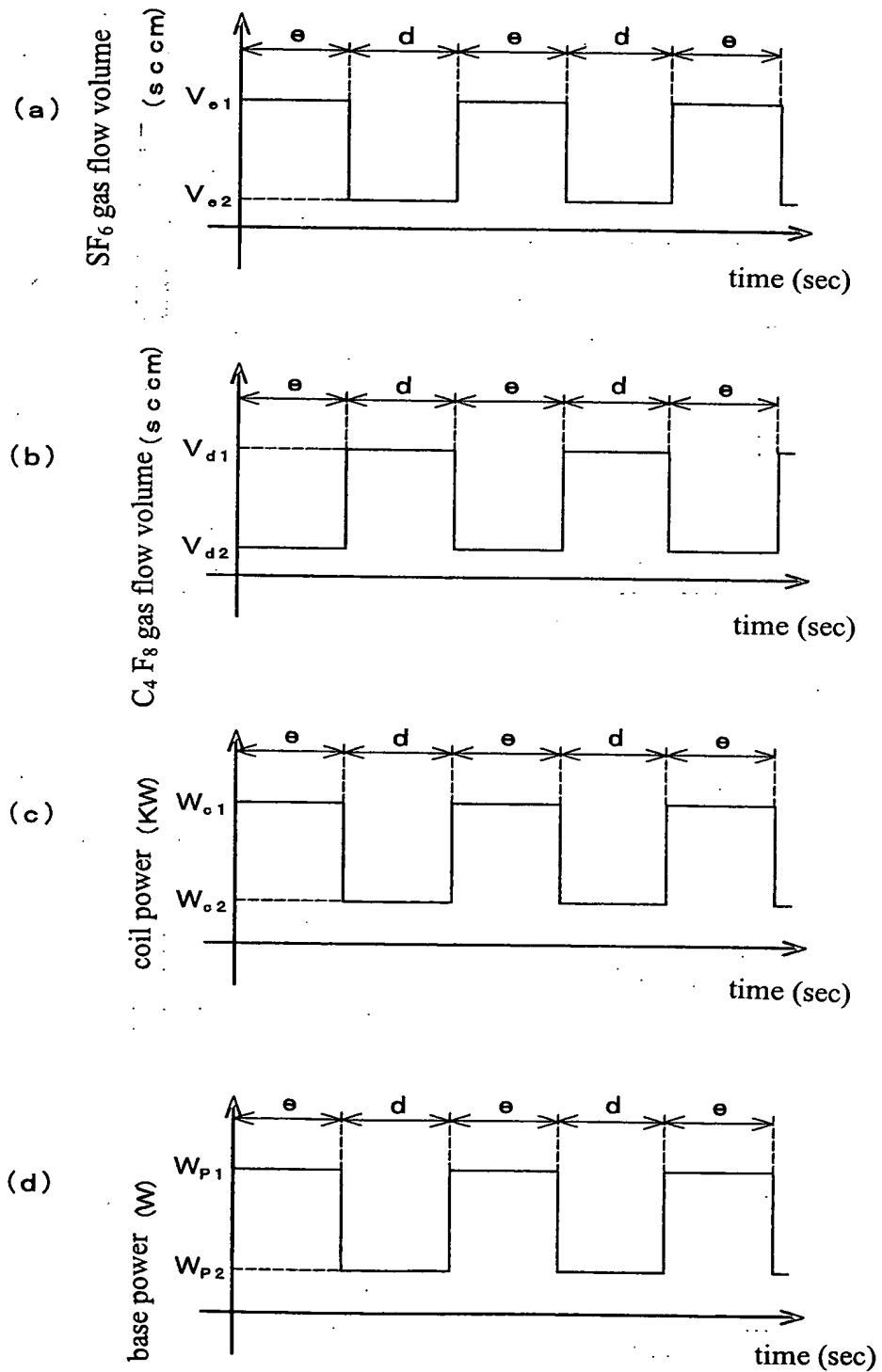
1 / 5

Fig. 1



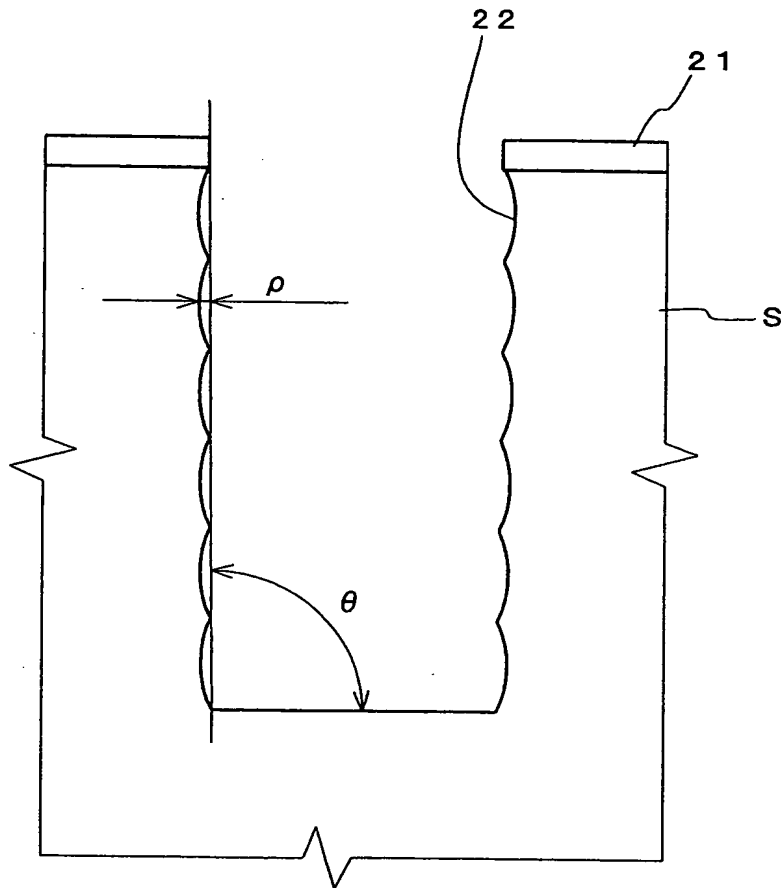
2/5

Fig. 2



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Fig. 3



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Fig. 4

	embodiment	comparative example
etching rate ($\mu\text{m}/\text{min}$)	3. 7	3. 4
mask selection ratio	1 4 0	1 0 4
unevenness	1 6 0	2 5 0
hole side wall angle	9 0. 2	9 0. 5

5 / 5

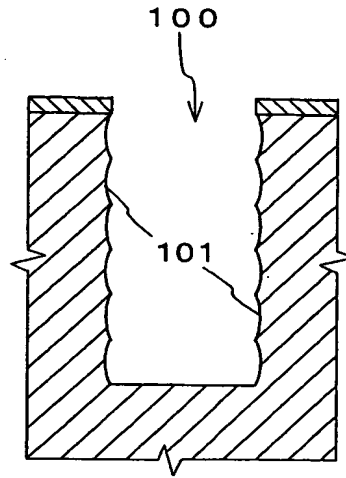


Fig. 5

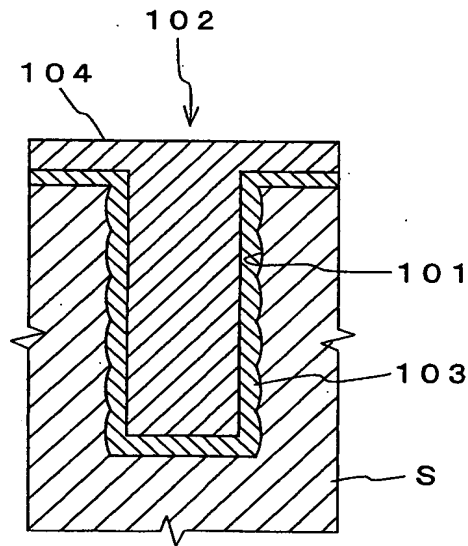


Fig. 6